

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

MICRON TECHNOLOGY, INC.,
Petitioner,

v.

PRESIDENT AND FELLOWS OF HARVARD COLLEGE,
Patent Owner

Case IPR No. 2017-00664
U.S. Patent No. 8,334,016
Title: VAPOR DEPOSITION OF METAL OXIDES, SILICATES AND
PHOSPHATES, AND SILICON DIOXIDE

PETITIONER'S UPDATED MANDATORY NOTICES

Mail Stop "PATENT BOARD"
Patent Trial and Appeal Board
U.S. Patent and Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Under the provisions of 37 C.F.R. § 42.8(b)(4)(i), Petitioner, Micron Technology, Inc., updates its email service address as follows:

Petitioner consents to email service at the following email addresses:

jason.lang@weil.com

jared.bobrow@weil.com

Micron.Harvard.IPR@weil.com

Lead and Back-Up Counsel, namely, Jeremy Jason Lang and Jared Bobrow, respectively, remain the same.

Dated: June 5, 2017

Respectfully submitted,



Jeremy Jason Lang
Lead Counsel for Petitioner
Registration No. 73,604
Weil, Gotshal & Manges LLP
201 Redwood Shores Parkway
Redwood Shores, CA 94065-1134
Telephone: 650-802-3237

CERTIFICATE OF SERVICE

The undersigned certifies, in accordance with 37 C.F.R. § 42.6(e), that service was made on the Patent Owner as detailed below.

<i>Date of Service</i>	June 5, 2017
<i>Manner of Service</i>	Electronic Mail
<i>Documents Served</i>	Petitioner's Updated Mandatory Notices
<i>Persons Served</i>	<u>Patent Owner's Counsel of Record</u> Reza Mollaaghababa, Lead Counsel USPTO Reg. No. 43,810 Pepper Hamilton LLC 125 High Street 19th Floor, High Street Tower Boston, MA 02110 mollaaghababar@pepperlaw.com BN_Harvard-IPR@pepperlaw.com

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Respectfully submitted,



Jeremy Jason Lang
Lead Counsel for Petitioner
Registration No. 73,604
Weil, Gotshal & Manges LLP
201 Redwood Shores Parkway
Redwood Shores, CA 94065-1134
Telephone: 650-802-3237